

Docket No.: 1268-093A



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Moshe FINAROV

U.S. Patent Application No. 09/626,793

Filed: July 26, 2000

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:  
: Confirmation No. 8657

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: Group Art Unit: 2851

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: Examiner: D. Esplin

For: APPARATUS FOR INTEGRATED MONITORING OF WAFERS AND FOR PROCESS  
CONTROL IN THE SEMICONDUCTOR MANUFACTURING AND A METHOD FOR  
USE THEREOF

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

Sir:

The following amendments and remarks are submitted in response to the Official Action  
dated May 13, 2003.

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